

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hiroshi MORIOKA**

Art Unit: **1756**

Application Number: **10/692,722**

Examiner: **Daborah Chako-Davis**

Filed: **October 27, 2003**

Confirmation Number: **9699**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR DEVICE
MANUFACTURING METHOD**

Attorney Docket Number: **032045**

Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

July 14, 2008

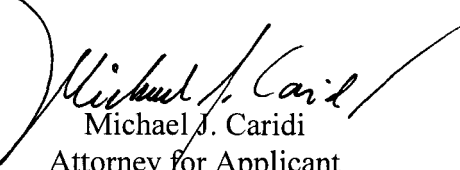
Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated February 13, 2008 for two months from May 13, 2008 to July 13, 2008 (Sunday).

Attached please find a credit card payment in the amount of \$460.00 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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